Attorney's Docket No.: 110348-133039

First Named Inventor: Lei Jiang Application No.: 10/728,550

Title: RINSE APPARATUS AND METHOD FOR WAFER POLISHER

REPLACEMENT SHEET

1/5

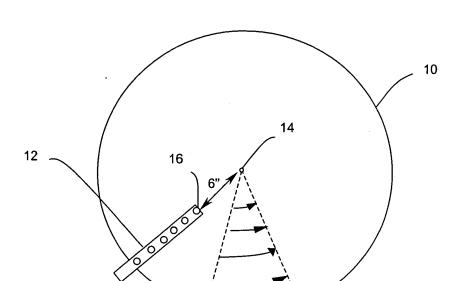


FIG. 1 (PRIOR ART)

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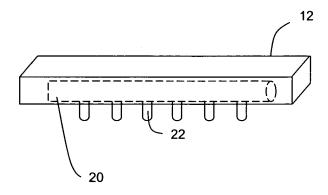


FIG. 2 (PRIOR ART)

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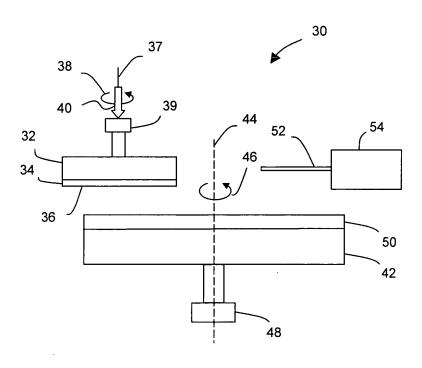
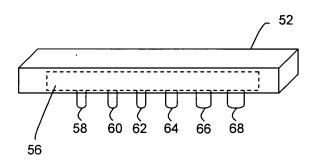


FIG. 3



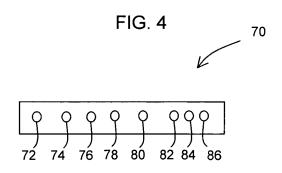


FIG. 5